



2815
Plw

501.37226VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. ITABASHI, et al.
Application No.: 09/961,291
Filed: September 25, 2001
For: SEMICONDUCTOR DEVICE HAVING WIRES AND
INSULATOR LAYERS WITH VIA-STUDS (AS AMENDED)
Group Art Unit: 2815
Examiner: E. Ortiz

**SUPPLEMENTING RESPONSE
(AMENDMENT)**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 22, 2004

Sir:

Supplementing the Response filed August 30, 2004, please amend the
above-identified application as listed in the following, and as set forth on the
following pages:

Amendments to the Claims; and

Remarks are included following the amendments.